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Patent

OCT 20 2006

Customer No.: 31561  
Docket No.: 12009-US-PA-1  
Application No.: 10/605,782

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Applicant : Shih-Chou Juan

Application No. : 10/605,782

Filed : 2003/10/27

For : METHOD FOR FORMING NITRIDED TUNNEL OXIDE  
LAYER

Art Unit : 2182

Examiner : Mohsen, Ahmadi

Interview Request

002-1- 571-273-5062

002-1-571-273-8300

(Via fax: 5 pages)

Examiner Mohsen,

It is noted with great appreciation that the application can be in condition for allowance. In response thereto, please find the attached supplemental amendment.

I may be contacted through email at [Belinda@jcipgroup.com.tw](mailto:Belinda@jcipgroup.com.tw).

Respectfully Submitted,

Date: Oct . 20 , 2006

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